| L Number | H1ts | Search Text | Ing | Time stamp |
|----------|------|---|-------------|------------------|
| | ~ | (sensor sensitive) and ((silicone silexane exessione enganosilane) near4 | US:PAT; | 2002/12/04 15:44 |
| | | (film layer)) and ((silicon- silozan- oxosilan- organosilane) same | US-PGPUR; | |
| | | (structure formula) same ladder) | EPO, JPO, | |
| | | | DERWEIT | |
| • | 9 - | diamond same (optical adj sensoi).ab.ti. | USPAT; | 2002/12/04 15:42 |
| | | | US - PGPUB; | |
| | | | EPO; JPO; | |
| | | | DERWENT | |
| • | 3 | | USPAT; | 2002/12/04 15:42 |
| | | | US-PGPUB; | |
| | | | EPO; JPO; | |
| | | | DERWENT | |
| 1 | ~ | (sensor sensitive) and ((silicone silomane omosilane organosilane) same | USPAT; | 2002/12/04 15:45 |
| | | (structure formula) same ladder) | US-PGPUB; | |
| | | | EPO; JPO; | |
| | _ | | DERWEIT | |
| | 7 | | USPAT; | 2002/12/06 13:30 |
| | | | US - PGPUB; | |
| | | | EPO; JPO; | - |
| | | | DERWEIIT | |
| • | ٠ | diamond same sensor.ab.ti. and (silicone silonane opesilane organosilane) | USPAT; | 2002/12/06 16:00 |
| | | | US-PGPUR; | |
| | | | EPO; JPO; | |
| | | | DERWENT | |
| | 5 % | (yasuda fukami taguchi kawano).in. and sensor and silicone and | USPAT; | 2002/12/09 10:07 |
| | | | US - PGPUB; | |
| | | | EPO; JPO; | |
| | | | DERWEIIT | |